


<b>Search Notes</b> 	<b>Application/Control No.</b> 10658929	<b>Applicant(s)/Patent Under Reexamination</b> LYM, KEVIN
	<b>Examiner</b> Mendoza, Junior O	<b>Art Unit</b> 2423

SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES		
Search Notes	Date	Examiner
Updated EAST Search	1/28/2009	JM
Inventor Search	1/28/2009	JM
<a href="http://www.ipdl.inpit.go.jp/homepg_e.ipdl">http://www.ipdl.inpit.go.jp/homepg_e.ipdl</a> (Japanese Patents)	1/28/2009	JM

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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